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(Not for submission under 37 CFR 1.99)

Application Number		10596647
Filing Date		2006-06-20
First Named Inventor		Peter Dirksen
Art Unit		1705 10596647 - GAU: 1721
Examiner Name		Thorl Chea
Attorney Docket Number		NL040617US1

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2	5610683			1997-03-11	TAKAHASHI	
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4	5373806			1994-12-20	LOGAR	
5	4509852			1985-04-09	TABARELLI ET AL	
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First Named Inventor	Peter Dirksen	
Art Unit	1765	10596647 - GAU: 1721
Examiner Name	Thorl Chea	
Attorney Docket Number	NL040617US1	

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	1	Yuuko Takano et al, "Top Antireflective Coating Process for 193nm Lithography", 1D 6.7, A3 Electronic Materials/Clariant Japan, Taiwan Semiconductor Manufacturing Co., Taiwan, R.O.C. XP10577400A, Page 100 No date of publication provided.	<input type="checkbox"/>

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